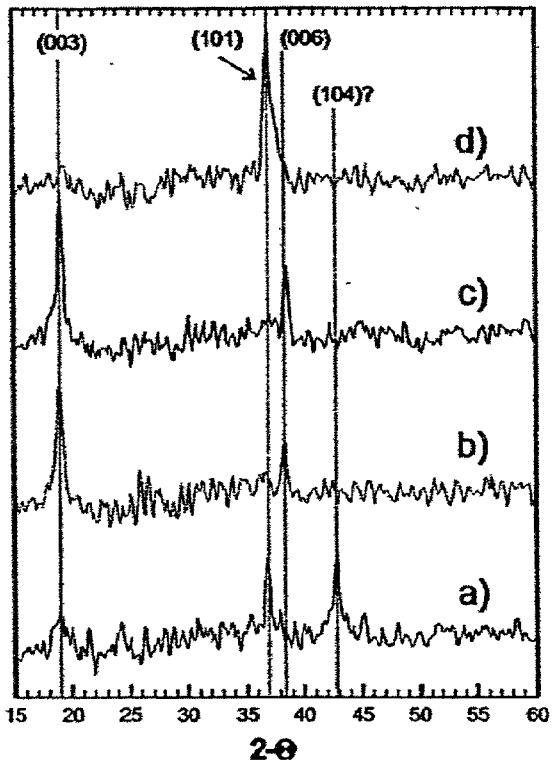
(003)
(101)
(006)
(104)?
d)
c)
b)
a)
15 20 25 30 35 40 45 50 55 60
2-Θ

FIG. 10

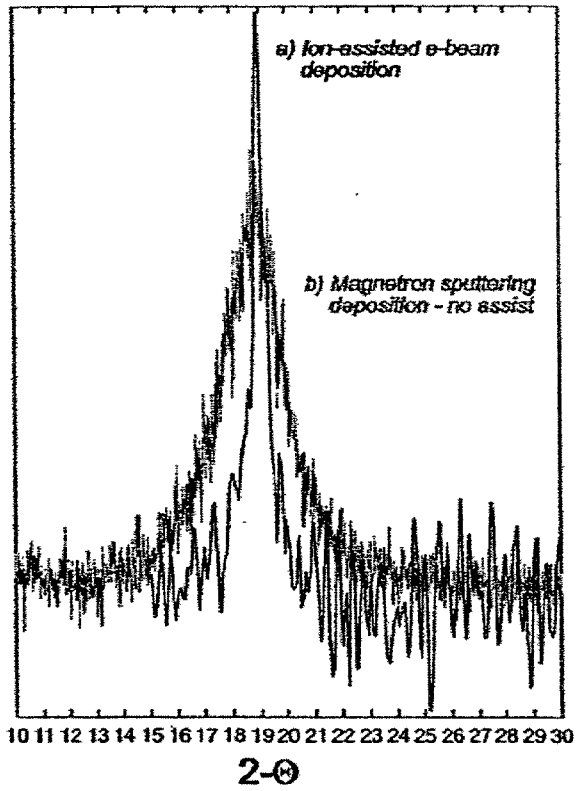
a) Ion-assisted e-beam deposition
b) Magnetron sputtering deposition - no assist
10 11 12 13 14 15 16 17 18 19 20 21 22 23 24 25 26 27 28 29 30
2-Θ

FIG. 11